

Background

Evidence suggests that a high density of dislocations correlates with poor optoelectronic performance in semiconductor based devices.

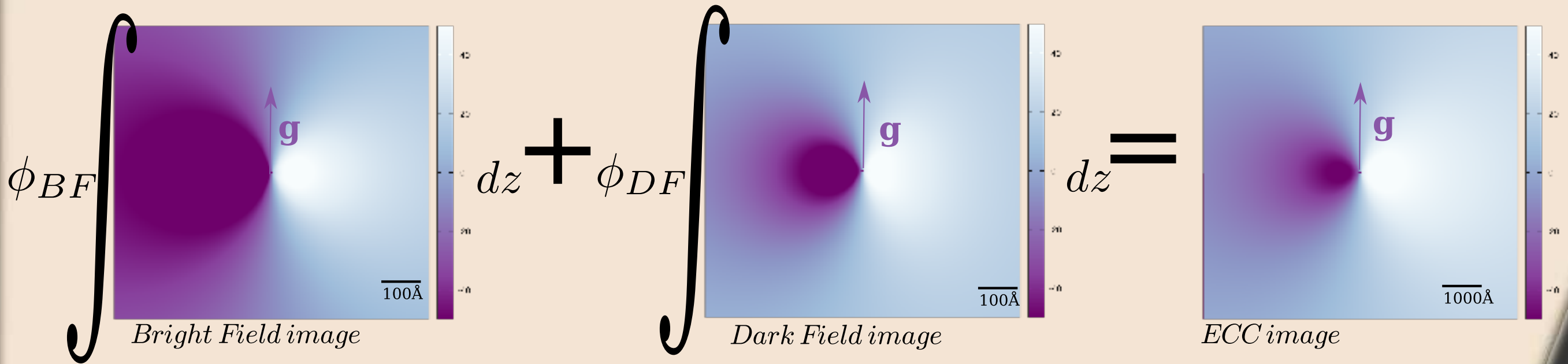
Threading dislocations (TDs) are line defects that run through the material and reach its surface. They are believed to act as non-radiative recombination centres affecting the luminescence output efficiency.

Dislocations bend the lattice of the perfect crystal introducing **local strain** providing a characteristic marker that can be observed. The electron microscope is one tool that measures this marker.

Electron channelling contrast imaging (ECCI) is a non-destructive scanning electron microscope technique that can provide material structural information by measuring the intensity of the backscattered electrons [1]. It is the purpose of this study to provide a model of the threading dislocation contrast thus observed.

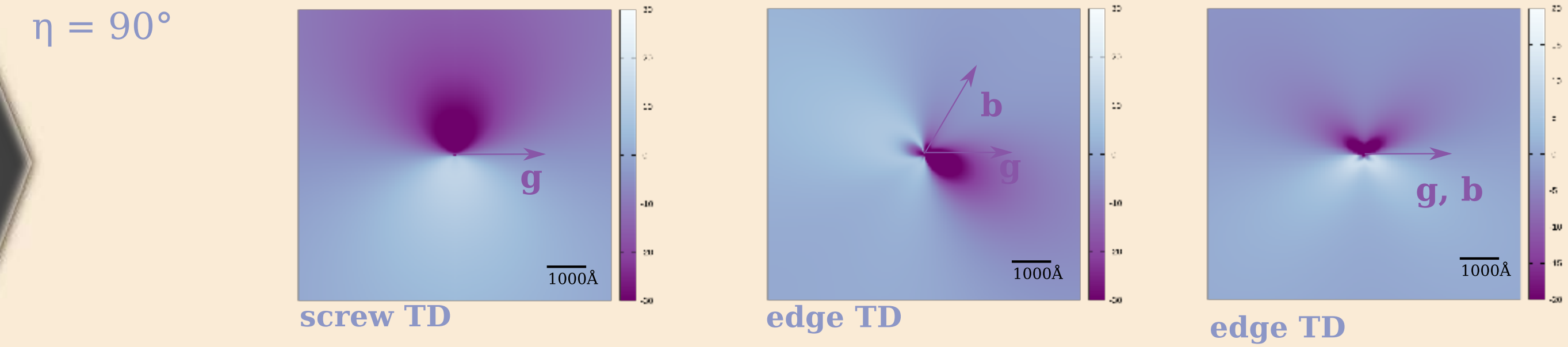
ECC images

Using the assumption that the backscattered signal comes from a single inelastic scattering event (Rossouw et al.[6]), the ECC image is then calculated as the weighted sum of the integrated BF and DF signal. The weighting factor is the cross section for impact ionisation (ϕ) for the given detector angle (α).

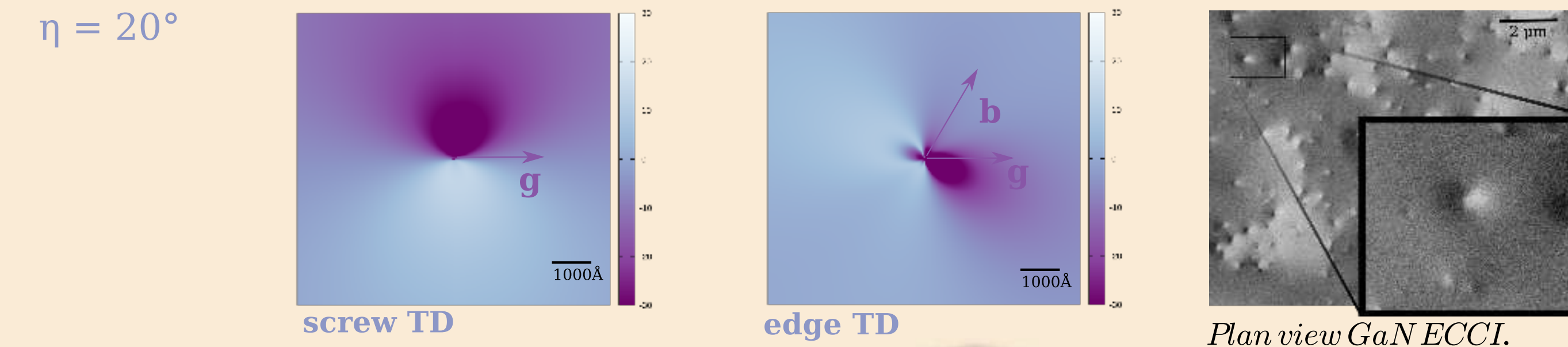


screw dislocation along GaN(0001)
[11-20] reflection
 $t = 0.5 \xi_g$
 $w = 0$
 α detector = 40°
 η sample = 90°

Backscatter geometry



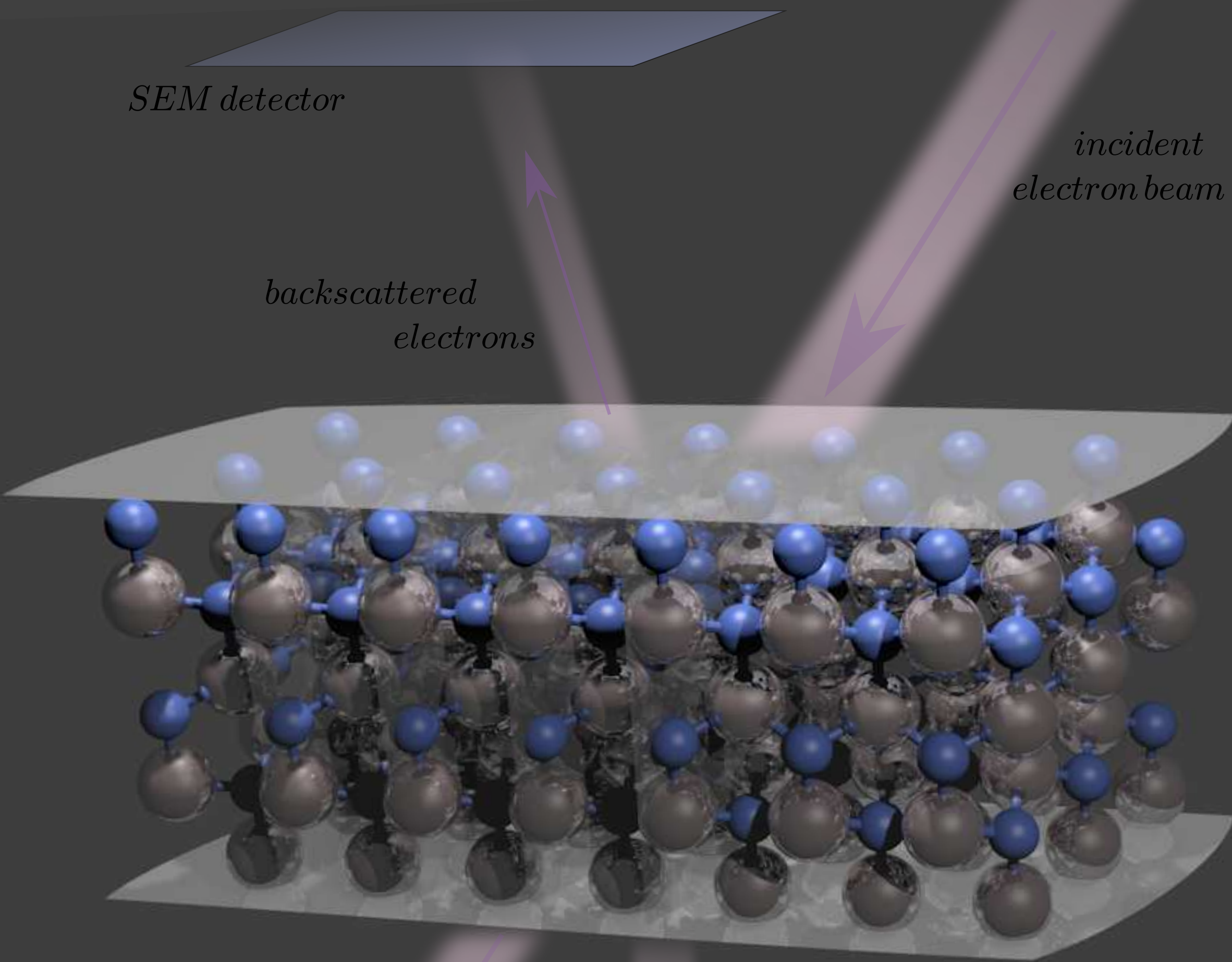
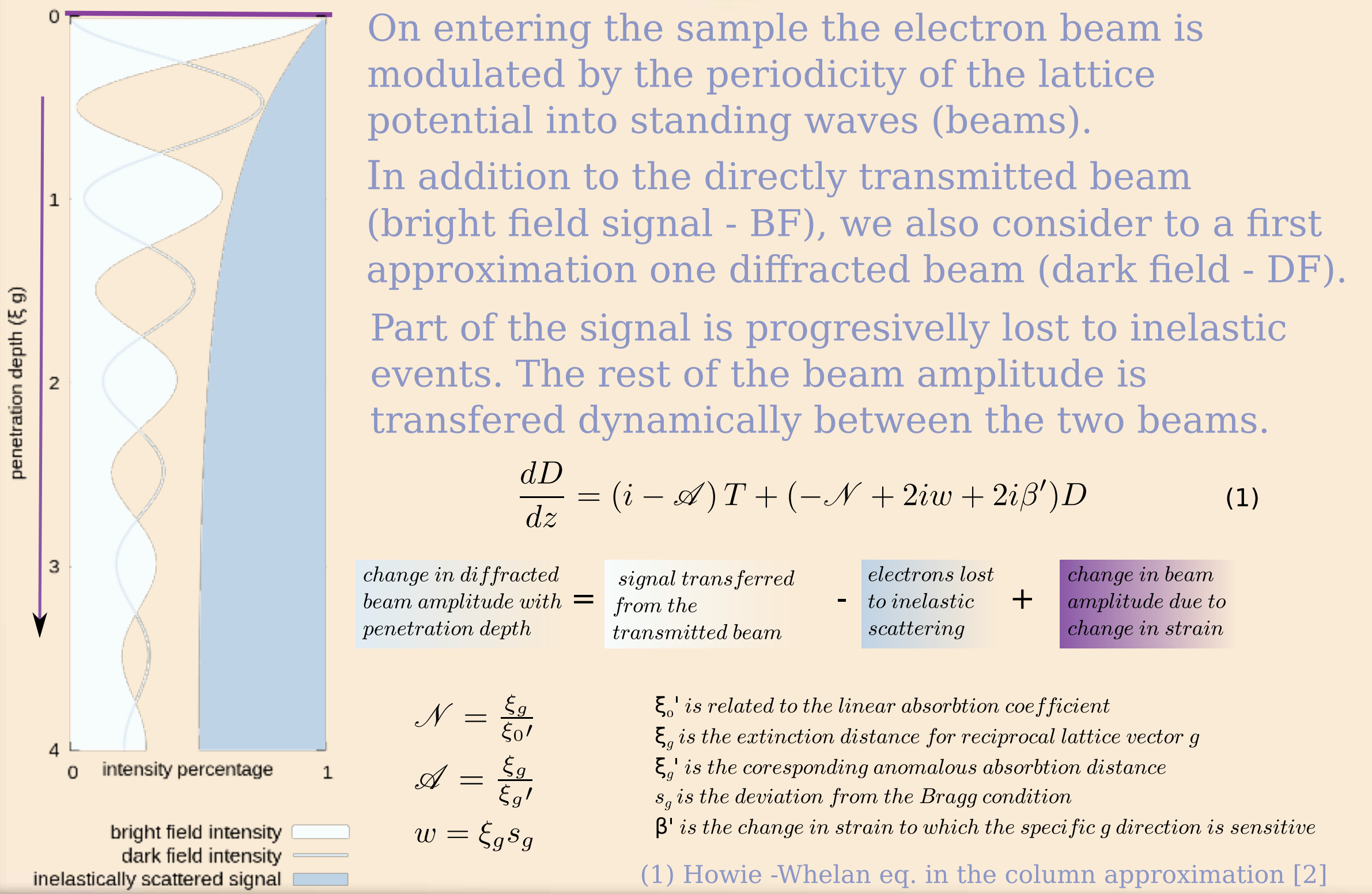
Foreshatter geometry



Plan view GaN ECCI.
By permission of Allehiani Nouf Mohammad

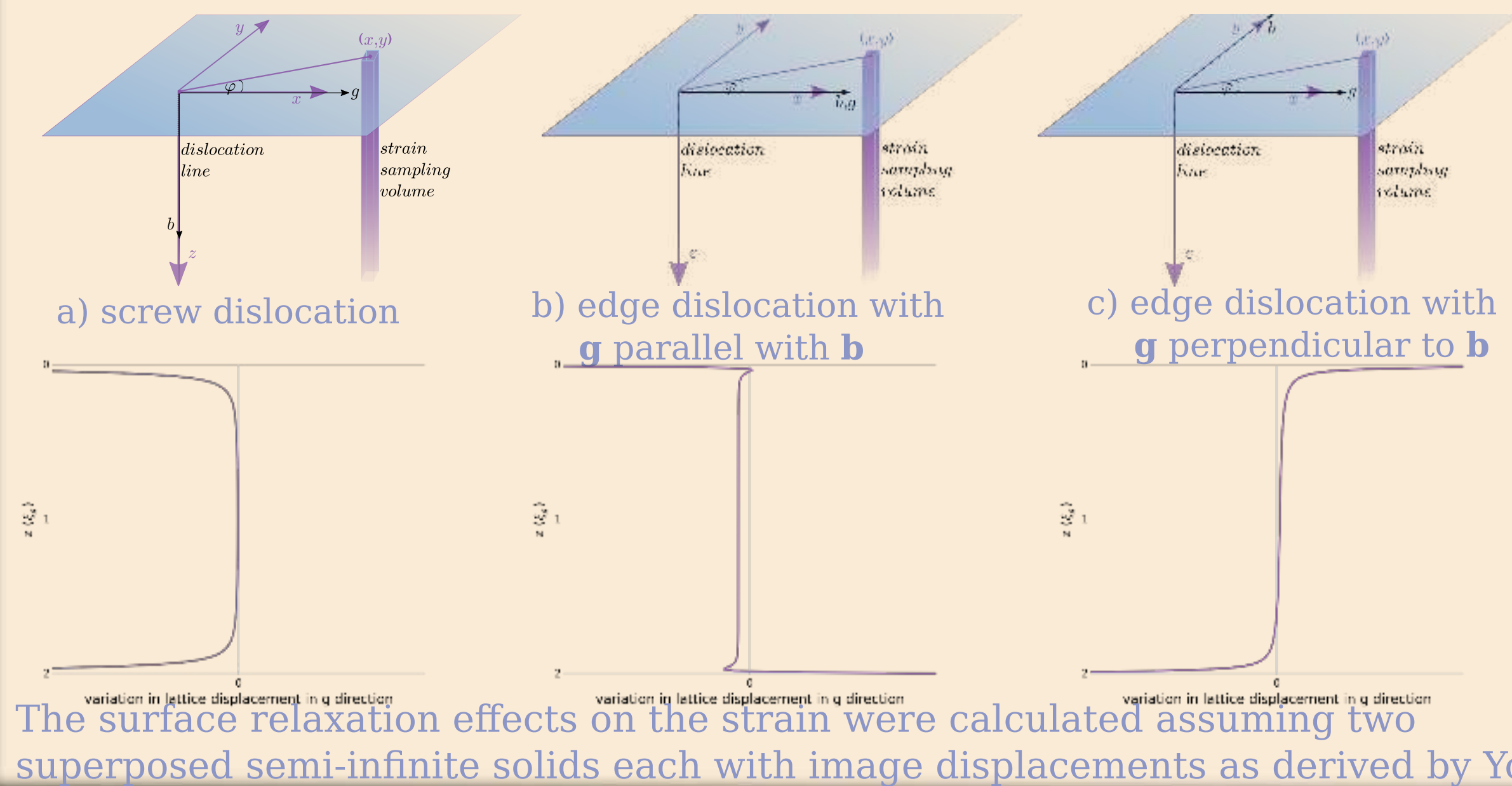
Theoretical model of contrast produced by surface normal TDs as observed by ECCI

Model



Bright Field beam
Dark Field beam
TEM detector

Strain variation through cubic crystal thin sample



$$\beta' = g \left(\frac{\partial u_g}{\partial z} \right)_{x,y} + \theta_B g \left(\frac{\partial u_g}{\partial r_g} \right)_z$$

where θ_B is the Bragg angle
 u_g is the lattice displacement parallel to g
 r_g is the coordinate in xy plane parallel to g

References:

[1] Kumar, N. G., et al. , 2012, *Phys. Rev. Lett.*, **108**, 13
[2] Howie, A., and Whelan, M. J., 1961, *Proc. Roy. Soc. A*, **263**, 217
[3] Yoffe, E. H., 1961, *Phil. Mag.*, **6**, 1147
[4] Tunstall, W. J. and Hirsch, P. B., 1964 *Phil. Mag.* , **9**, 97
[5] Follstaedt, D. M., et al. , 2003, *Appl. Phys. Lett.* **83**, 4797
[6] Rossouw, P. R., et al., 1994, *Phil. Mag. A*, **70**, 985

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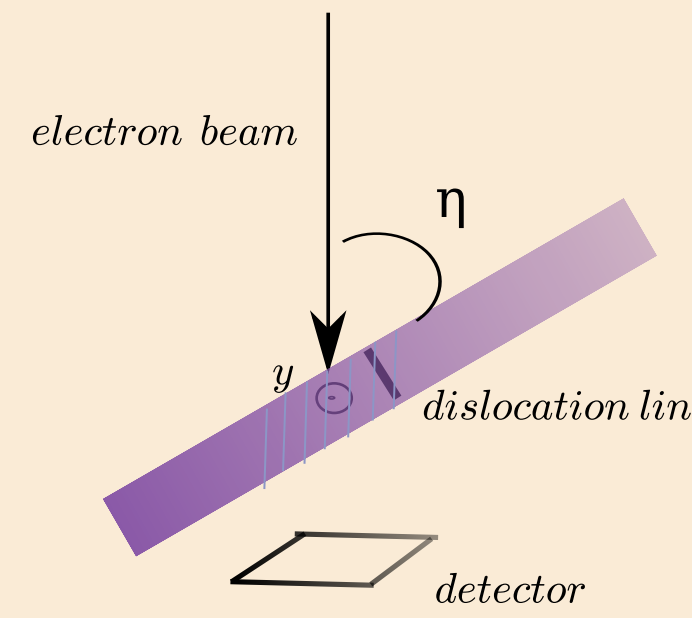
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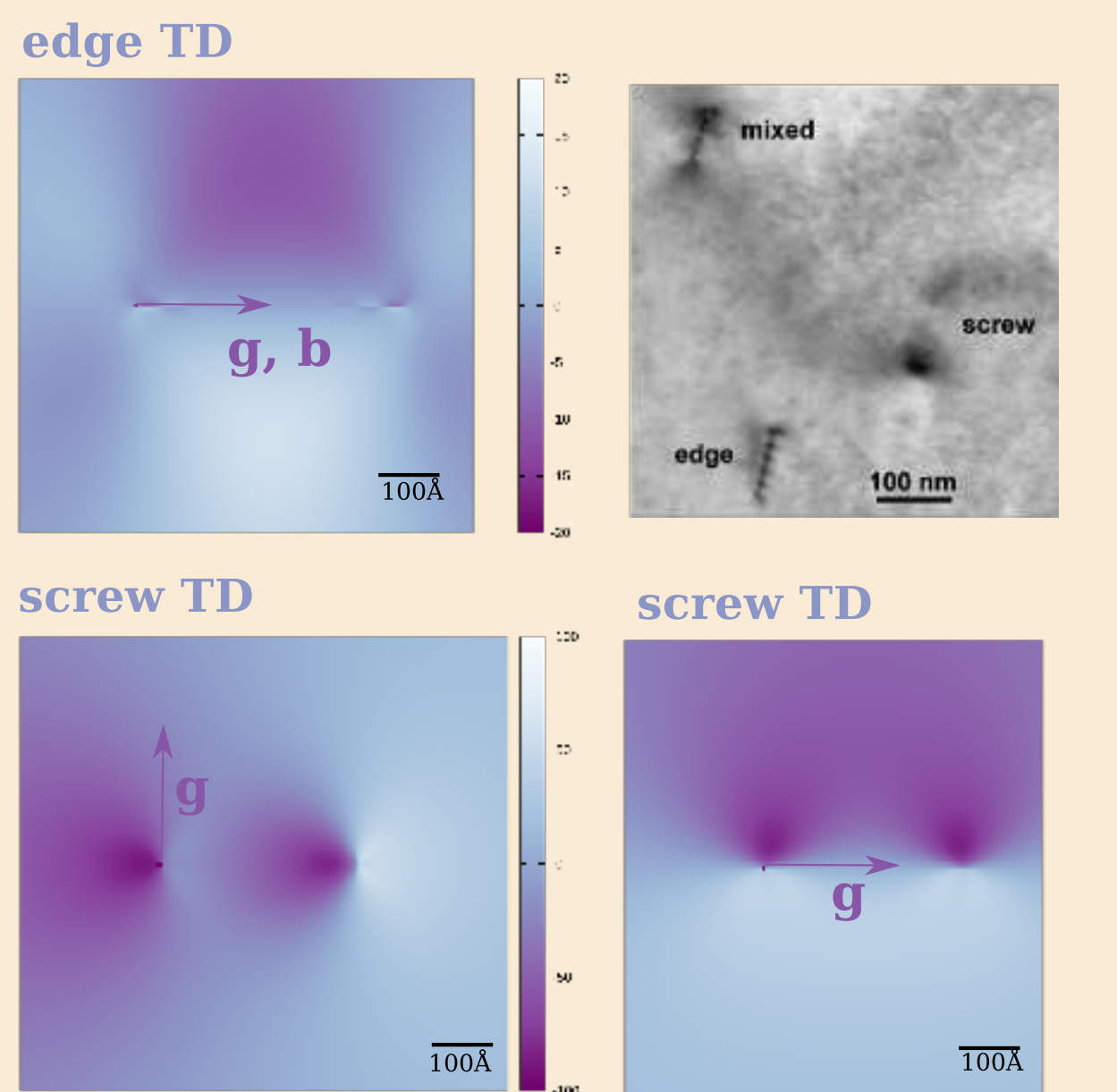


Tilting the sample

[0001] orientation
 $\eta = 78^\circ$
 $y = (11-20)$
 $t = 5 \xi_g$
 $w = 0.2$

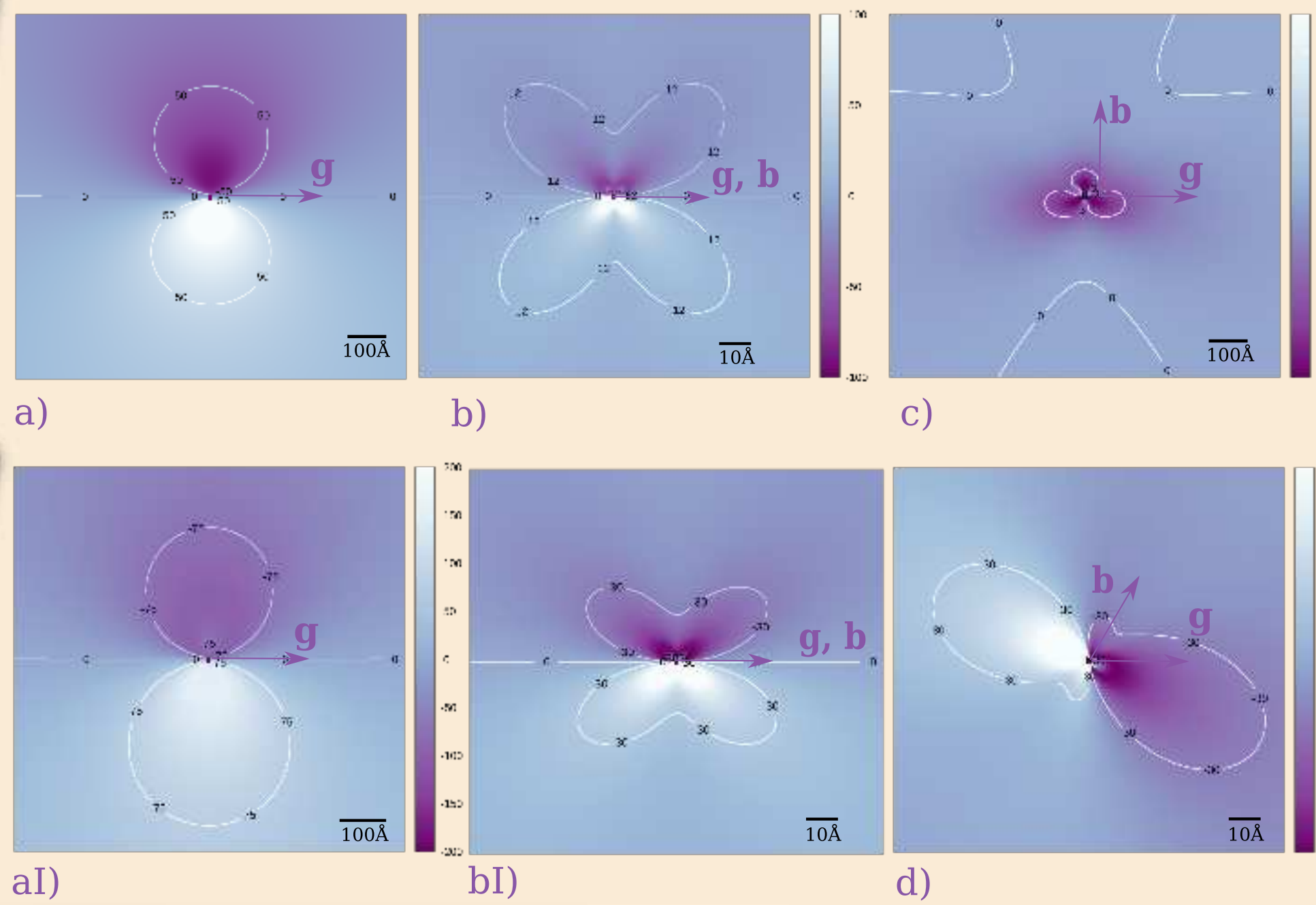


Can be easily modelled by rotating the coordinate system of the strain field by an angle η with respect to the y-axis. The integrating columns will remain along the direction of the incident beam. The simulated images show good qualitative resemblance to the experimental work of Follstaedt et al. [5].



The imaging reflection is chosen such that the invisibility criterion is achieved for the screw dislocation in the bulk of the sample

TEM bright field images



cubic Cu system

The contrast plots obtained by numerical integration of the dynamical equations show good agreement with the work of Tunstall et al.[4].

$\mathcal{A} = 1$	$\mathcal{N} = 10$	$\theta_B = 0.015$	$\nu = 0.30$
a) (311) reflection	b) (202) reflection	c) (111) reflection	
$ g \cdot b = 2.3$	$ g \cdot b = 2$	$ g \cdot b = 1.2$	
$w = 0.16$	$w = 0.12$	$w = 0.03$	
$t = 5.5 \xi_g$	$t = 2.5 \xi_g$	$t = 5.5 \xi_g$	
$\xi_g = 300 \text{ \AA}$	$\xi_g = 470 \text{ \AA}$	$\xi_g = 270 \text{ \AA}$	

wurtzite GaN system

$\mathcal{A} = 1$	$\mathcal{N} = 2$	$\theta_B = 0.006$	$\nu = 0.26$
a1) (11-20) reflection	b1) (2-1-10) reflection	d) (11-20) reflection	
$ g \cdot b = 3.25$	$ g \cdot b = 2$	$ g \cdot b = 2$	
$w = 0.2$	$w = 0.0$	$w = 0.0$	
$t = 0.5 \xi_g$	$t = 0.5 \xi_g$	$t = 0.5 \xi_g$	

The extinction distances were calculated using Weickenmeier-Kohl scattering factors. Elastic constants were derived using Voigt average.